INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 14, 2026

IGI Report Number	LG817692177
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MIXED CUT
Measurements	9.39 X 5.89 X 3.59 MM

GRADING RESULTS

Carat Weight	2.01 CARATS
Color Grade	E
Clarity Grade	VVS 1

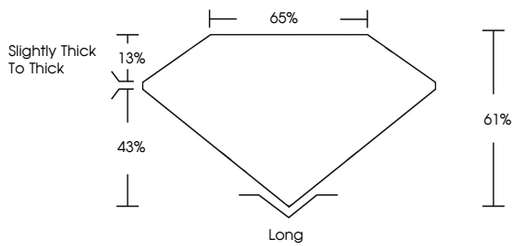
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG817692177

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG817692177
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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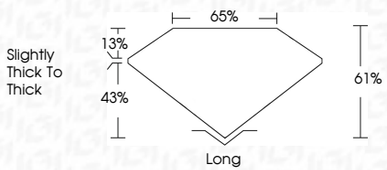

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IGI

July 14, 2026
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CUT CORNERED RECT. MIXED CUT
9.39 X 5.89 X 3.59 MM
Carat Weight 2.01 CARATS
Color Grade E
Clarity Grade VVS 1
Depth 61%
Table 65%
Girdle Slightly Thick To Thick
Culet Long
Polish VERY GOOD
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG817692177
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa